

APPLICANT'S ART CITATION <i>O I P E</i> <small>(Use several sheets if necessary)</small> <small>JUL 9 1 2001</small>	Application 10/042,790		OFGS File No. P/189-166				
	Applicant Jose Ignacio Bueno RUIZ et al.						
	Filing Date January 8, 2002		Group Art Unit 2836				
	U.S. PATENT DOCUMENTS						
Initial	Document Number	Date MM-YYYY	Name	Class	Sub-class	Filing Date If Appropriate	
	US-5,282,709	02-1994	Chaput et al.	411	433		
US-4,941,790	07-1990	Kim	411	432			
US-5,722,709	03-1998	Lortz et al.	294	86.4			
US-5,160,233	11-1992	McKinnis	411	433			
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FOREIGN PATENT DOCUMENTS							
	Document Number	Date MM-YYYY	Country	Class	Sub-class	Translation	
						Yes	No
<i>Sh</i>	WO 00/17051	03-2000	PCT	<i>B64G</i>	<i>1/64</i>	X (Abstract Only)	
<i>Sh</i>	07187094	07-1995	Japan	<i>B64G</i>	<i>1/64</i>	X (Abstract Only)	
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)							
<i>Examiner</i> <i>As Jackson</i>	Date Considered 1-23-04						
<small>EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and considered. Include copy of this form with next communication to the applicant.</small>							